

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention

CHEMICAL TREATMENT TO RETARD DIFFUSION IN A
SEMICONDUCTOR OVERLAYER

Application Number :

Confirmation Number:

First Named Applicant: Kevin Chan

Attorney Docket Number: FIS920040027

Art Unit:

Examiner:

Search string: (5731626 or 5967794 or 6043139 or 6271551).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5731626	1998-03-24	Eaglesham et al.			
	2	5967794	1999-10-19	Kodama			
	3	6043139	2000-03-28	Eaglesham et al.			
	4	6271551	2001-08-07	Schmitz et al.			

Signature

Examiner Name	Date